

RESPONSE UNDER 37 CFR 1.116 EXPEDITED PROCEDURE - EXAMINING GROUP 2620

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants

Tatsuya Kato et al.

Application No.

10/516,701

Filed

December 1, 2004

For

METHOD FOR DETERMINING PATTERN FOR MODULATING

POWER OF LASER BEAM, AN APPARATUS FOR RECORDING DATA IN OPTICAL RECORDING MEDIUM AND OPTICAL

RECORDING MEDIUM

NOK to Endn"

Examiner

Minerva Rivero

Art Unit

2627

Docket No.

890050.514USPC

Date

January 22, 2007

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR 1.116

Commissioner for Patents:

In response to the Office Action dated October 20, 2006, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.

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